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Facsimile Transmittal Sheet

DATE July 19, 2001

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EXAMINER IS AWAITING THIS FAX!!

NAME Examiner Ed Glick

FIRM U.S.P.T.O

PHONE

FAX 703-305-0844

CLIENT/MATTER 09794353-0005

FROM Christopher P. Rauch

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MESSAGE

APPLICANT(S): Mitsuhiro Nakamura et al.. OLD DOCKET NO.: P97,0322
NEW DOCKET NO.: 09794353-0005
SERIAL NO.: 08/809,463 GROUP ART UNIT: 2814
DATE FILED: July 18, 1997 EXAMINER: P. Cao
INVENTION: "MULTI-LAYERED STRUCTURE FOR FABRICATING AN
OHMIC ELECTRODE AND OHMIC ELECTRODE"

See attached.

Original will NOT be mailed

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
SUPPLEMENT TO PETITION TO WITHDRAW ABANDONMENT
OF APRIL 3, 2001

APPLICANT(S): Mitsuhiro Nakamura et al. OLD DOCKET NO.: P97,0322
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SERIAL NO.: 08/809,463 GROUP ART UNIT: 2814
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OHMIC ELECTRODE AND OHMIC ELECTRODE"

Hon. Assistant Commissioner for Patents
Washington, DC 20231

S I R:

This Supplement to the Petition to Withdraw Abandonment mailed on April 3, 2001 presents a statement under 37 C.F.R. §1.8(b)(3).

Enclosed with the Petition of April 3, 2001 was a copy of a Request for Rehearing showing a Certificate of Mailing certifying that the Request for Rehearing was mailed to the U.S. Patent and Trademark Office on January 29, 2001. Also enclosed is was copy of the self-addressed post card, which has not been returned from the U.S. Patent and Trademark Office.

I, Christopher P. Rauch, hereby declare that I personally signed the Certificate of Mailing on January 29, 2001, and personally timely deposited the correspondence as First Class Mail on that date.

Applicants have therefore timely filed a response to the Decision on Appeal of November 28, 2000 in the present application utilizing the Certificate of Mailing procedures. The abandonment is therefore an error and withdrawal of the abandonment is accordance with 37 C.F.R. §1.181(a) and early rehearing of the appeal in the present application is hereby requested.

Respectfully submitted,

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CERTIFICATE OF TRANSMISSION

I hereby certify that this correspondence is being transmitted via facsimile to telephone number 703-305-0844 at the U.S.P.T.O. and addressed to Examiner Ed Glick on July 19, 2001.

Christopher P. Rauch (Reg. No. 45,034)
Christopher P. Rauch

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